



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

September 9, 2026

IGI Report Number

LG835673397

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

EMERALD CUT

Measurements

10.23 X 6.75 X 4.49 MM

GRADING RESULTS

Carat Weight

3.08 CARATS

Color Grade

F

Clarity Grade

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

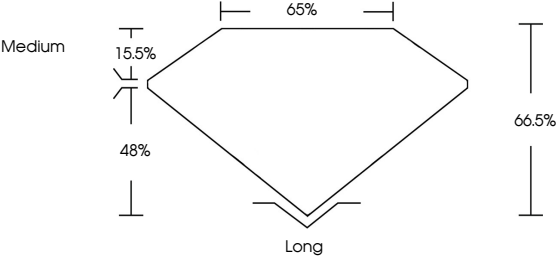
Inscription(s)

 LG835673397

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

Report verification at igi.org

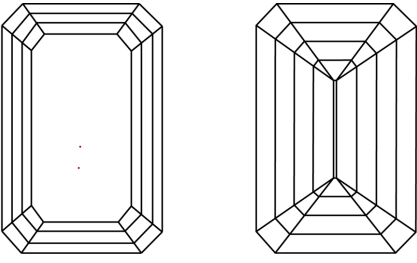
PROPORTIONS



Medium

Long

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

Sample Image Used



COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS 1-2 VS 1-2 SI 1-2 I 1-3

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included

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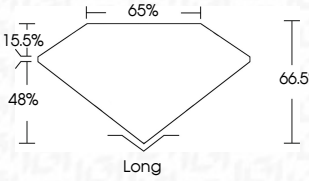
Fluorescence

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IGI



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EMERALD CUT

3.08 CARATS
F

10.23 X 6.75 X 4.49 MM

Carat Weight
Color Grade
Clarity Grade
Table
Girdle

3.08 CARATS
F
VVS 2
66.5%
65%
Medium

Long
EXCELLENT
EXCELLENT
NONE
IGI LG835673397

Culet
Polish
Symmetry
Fluorescence
Inscription(s)

None
EXCELLENT
EXCELLENT
NONE
IGI LG835673397

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